



2825

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

PATENT APPLICATION

In re application of

Hidemitsu AOKI, et al.

Appln. No.: 10/071,184

Confirmation No.: 2961

Filed: February 11, 2002

Docket No: Q68480

Group Art Unit: 2823

Examiner: Michelle Estrada

For: MANUFACTURING METHOD OF SEMICONDUCTOR DEVICE

RESPONSE UNDER 37 C.F.R. § 1.111

MAIL STOP NON-FEE AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated May 6, 2003, please consider the remarks as submitted herewith on the accompanying pages.

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